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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
(Case No. 219.005-C1-US)

In the Application of: **Yamada et al.**

Serial No: **10/790,276**

Filed: **March 1, 2004**

Title: **Production Managing System of Semiconductor Device**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

) Group
) Art Unit: **2825**
)
) Examiner:

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on June 23, 2004

Date
Michiko Site
(person signing this certificate)

Michiko Site
Signature

FIRST INFORMATION DISCLOSURE STATEMENT

Dear Sir:

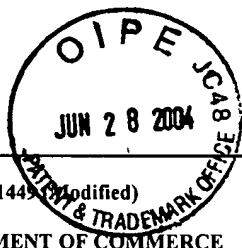
Submitted herewith is one (1) sheet of a modified Form PTO-1449. All of the documents listed on the modified Form PTO-1449 were provided or cited in the parent application of the above-captioned application. Accordingly, the documents are not enclosed herewith. (See 37 C.F.R. §1.98(d) and MPEP 609). Should the Examiner desire an additional copy of the documents, kindly contact the undersigned.

It is respectfully requested that the Examiner make his/her consideration of these documents formally of record with the initial Office Action.

Respectfully submitted,

Date: June 23, 2004

Neil A. Steinberg
Reg. No. 34,735
650-968-8079



PTO-1449 (Modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE STATEMENT BY APPLICANT	ATTY. DOCKET NO. 219.005-C1-US	SERIAL NUMBER 10/790,276
	APPLICANT(S) Yamada et al.	
	FILING DATE March 1, 2004	GROUP ART UNIT 2825

U.S. PATENT DOCUMENTS

EXAMINER INITIALS	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE
	4,571,685	2/1986	Kamoshida			
	6,055,463	4/2000	Cheong et al.			
	6,314,379	11/2001	Hu et al.			
	6,338,001	1/2002	Steffan et al.			
	6,542,830	4/2003	Mizuno et al.			

FOREIGN PATENT DOCUMENTS

EXAMINER INITIALS	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION YES/NO	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER	DATE CONSIDERED
EXAMINER: Initial citation if reference was considered. Draw line through citation if not in conformance to MPEP 609 and not considered. Include copy of this form with next communication to applicant.	